

FIG. 2

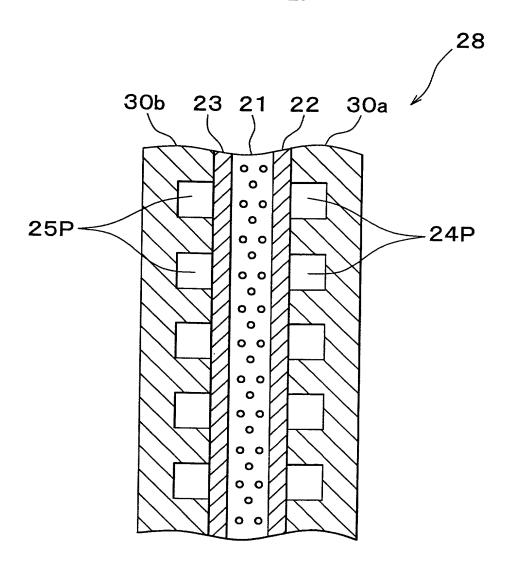
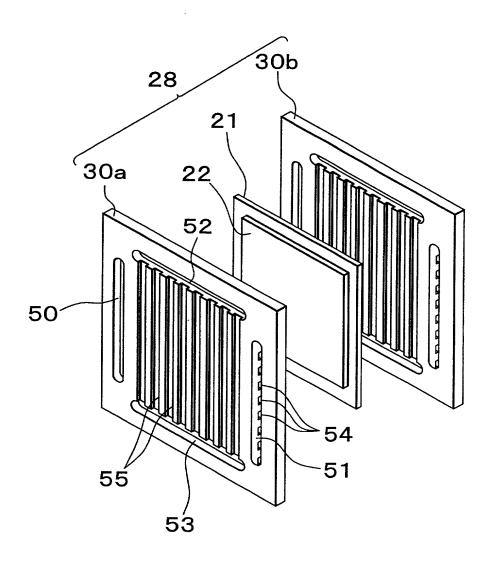
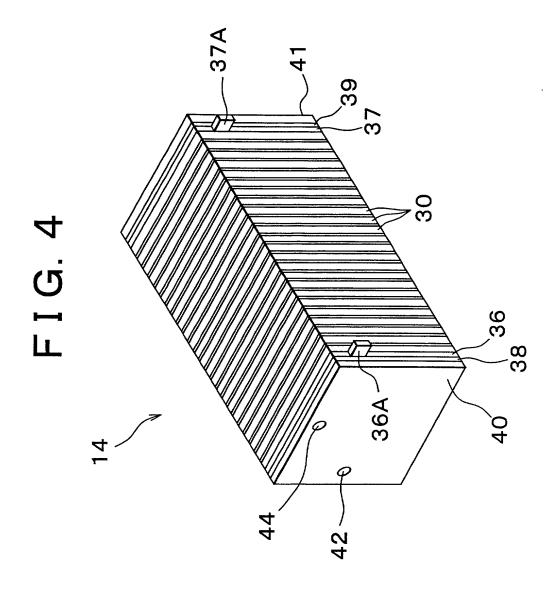
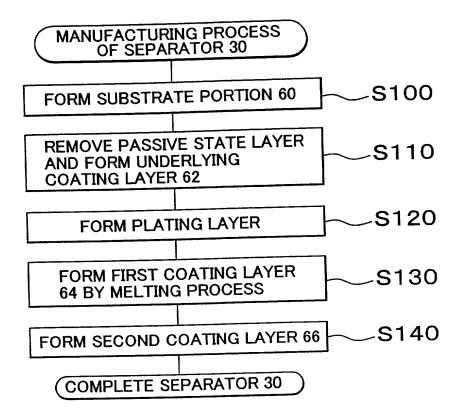


FIG. 3







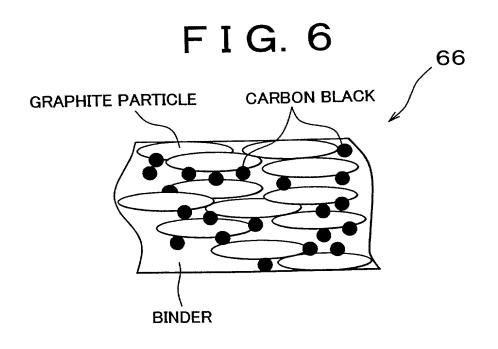


FIG. 7A

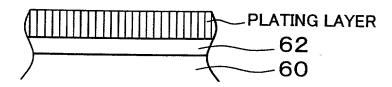


FIG. 7B



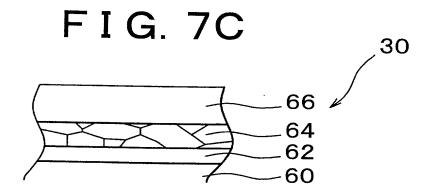
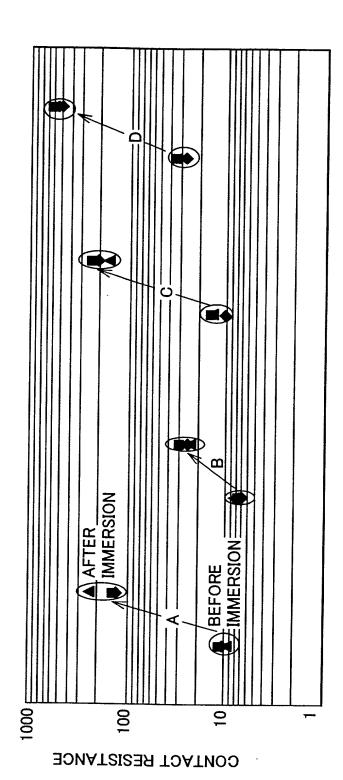


FIG. 8



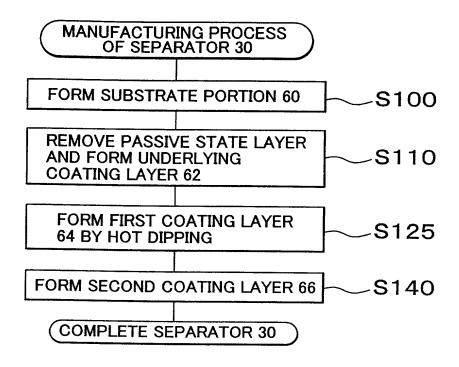
A: Sn-Bi, WITHOUT MELTING PROCESS

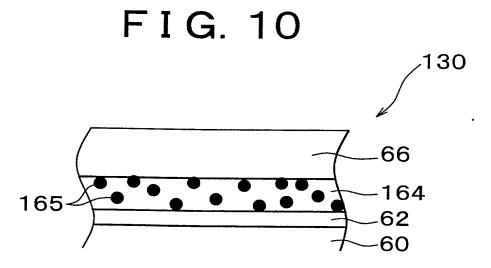
B: Sn-Bi, WITH MELTING PROCESS (AIR-COOLING)

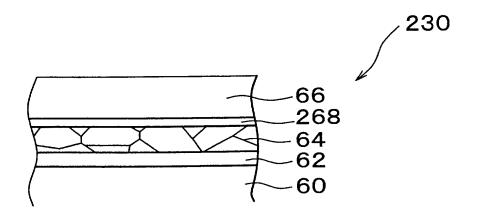
C: Sn-Bi, WITH MELTING PROCESS (WATER-COOLING)

D : Sn, WITH MELTING PROCESS (AIR-COOLING)

FIG. 9

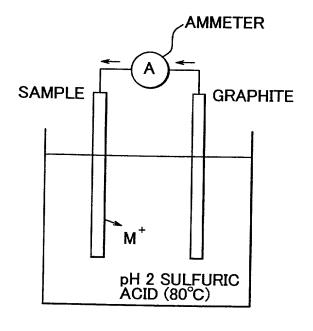






SURFACE TREATMENT	CORROSION CURRENT*1 (µ A/cm²)	CONTACT RESISTANCE *2 (mΩc㎡)
E:0.1 μ mAg/10 μ mCu	6.9	10 OR LESS
F:0.1 μ mAg/10 μ mSn(UNPROCESSED) /10 μ mCu	21.9	10 OR LESS
G:0.1 μ mAg/10 μ mSn(MELTING PROCESS) /10 μ mCu	0.3	10 OR LESS

- * 1: RESULT OBTAINED WITHOUT CARBON COATING LAYER OF CARBON MATERIALS
- * 2: RESULT OBTAINED WITH CARBON COATING LAYER OF CARBON MATERIALS



CORROSION CARBON COATING COATING LAYER*	PRESENT PRESENT	NONE		
CORF -RES COAT LAYE	PRE	NONE		
CONDUCTIVE PARTICLES*	PRESENT	NONE		
METAL COATING LAYER*	METAL HAVING LOWER MELTING POINT THAN MATERIAL OF	SEPARATOR BASE MATERIAL	AND HAVING BEEN SUBJECTED TO MELTING	PROCESS OR METAL HAVING
PREDETER MINED PROCESS*	PRESENT	NONE		
SEPARATOR PREDETER BASE MATERIAL* PROCESS*	PRESENT			

*: ANY MATERIAL AS DESCRIBED IN THE SPECIFICATION CAN BE SELECTED AS APPROPRIATE